

211909US-2 CIP



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OCT 24 2003

TC 1700

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

ATSUMI YAMAGUSHI, ET AL.

: EXAMINER: DEO, DUY VU
NGUYEN

SERIAL NO: 09/915,396

:

RCE HERewith
FILED:

: GROUP ART UNIT: 1765

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

*do not
enter* (initials)

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
ALEXANDRIA, VA 22313

SIR:

In response to the Office Action dated July 24, 2003, please amend the above-
identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Amendments to the Drawings begin on page 9 of this paper and include attached
replacement sheets (4).

Remarks/Arguments begin on page 10 of this paper.